



17<sup>TH</sup> ADVANCED BEAM DYNAMICS WORKSHOP ON

**FUTURE LIGHT SOURCES**

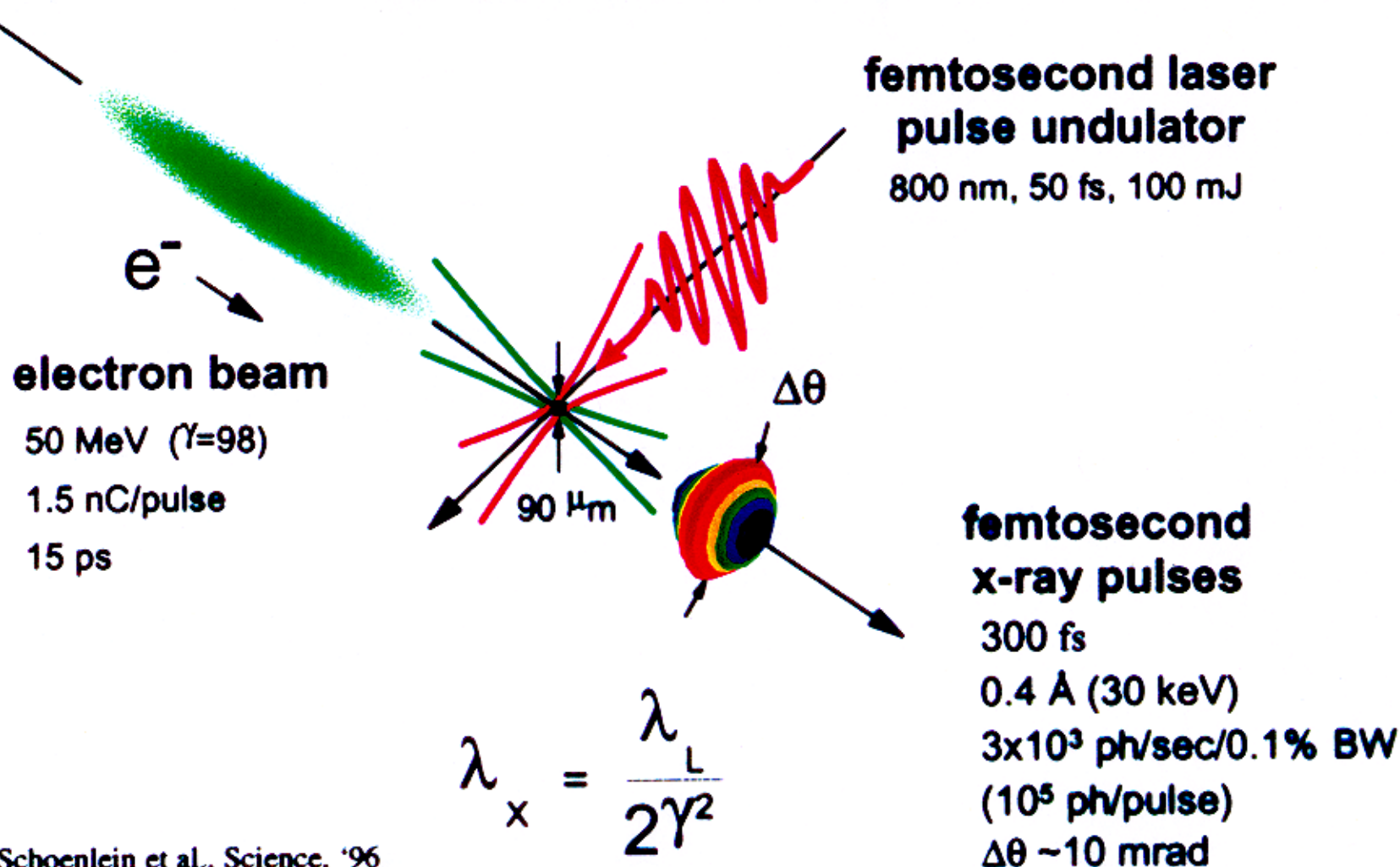
# **Laser and Transition Radiation-Based Electron Beam Diagnostics at High Energies**

*W. Leemans, LBNL*

APRIL 6-9, 1999

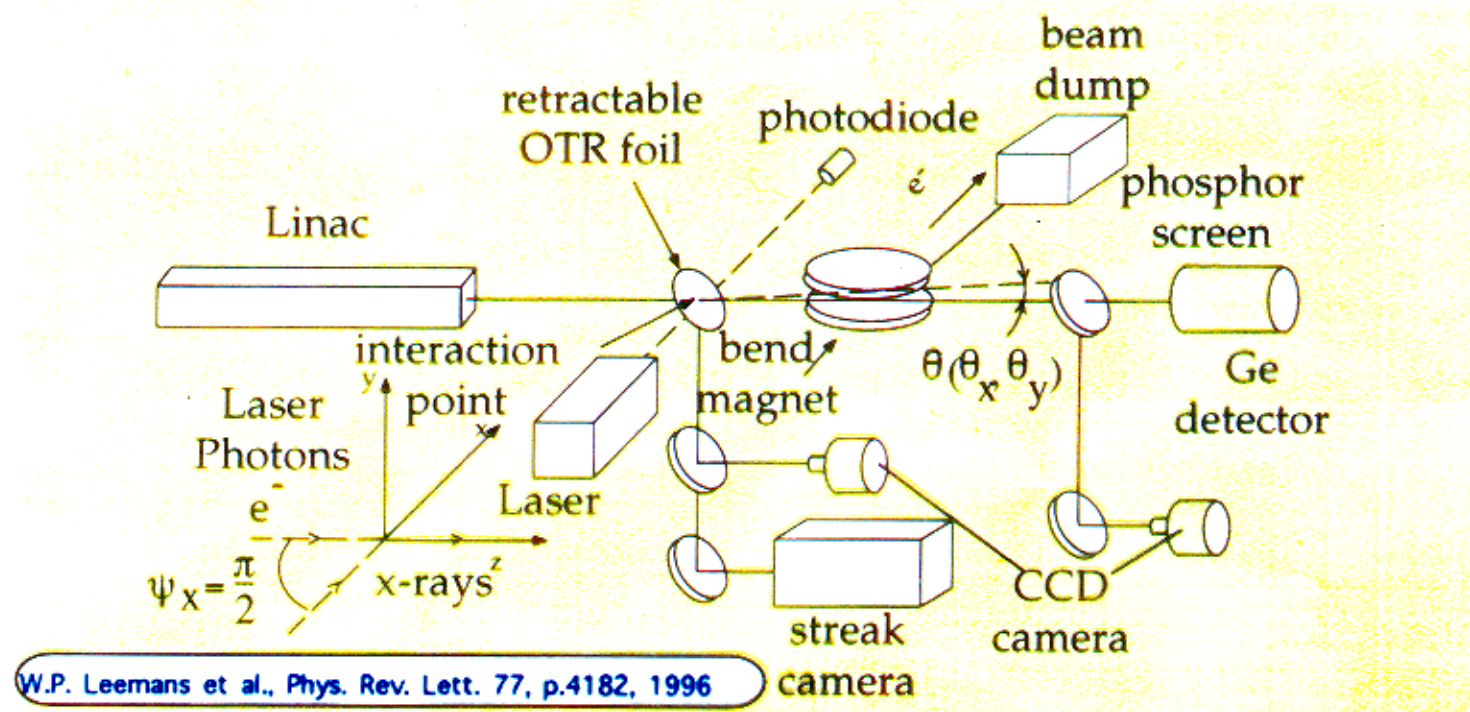
ARGONNE NATIONAL LABORATORY, ARGONNE, IL U.S.A.

# 90° Thomson Scattering

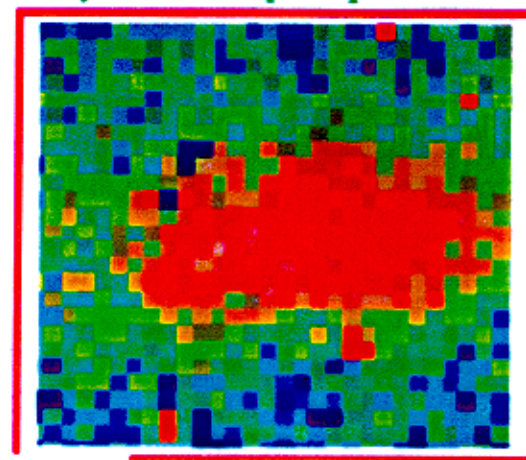


R.W. Schoenlein et al., Science, '96  
W.P. Leemans et al., PRL '96, JQE '97

# Thomson Scattering Phase-Space Diagnostic at the Beam Test Facility



x-ray beam on phosphor screen



- X-rays detected with Gd<sub>2</sub>O<sub>3</sub>:Tb screen imaged onto 16 bit CCD camera
- Phosphor screen response calibrated with  $I^{129}$ ,  $Am^{241}$
- Phosphor used to collect beam image and measure total x-ray yield

# Beam divergence from x-ray spectra

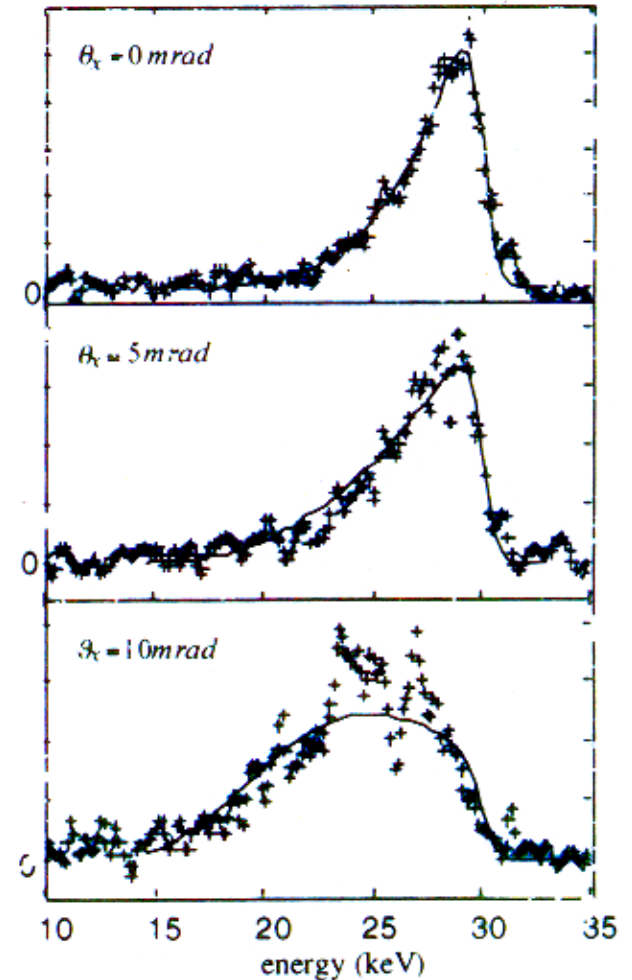
detection sensitivity

$$\frac{dn}{d\theta_x d\theta_y d\kappa} \propto \int_0^{2\pi} d\phi [1 - 4\kappa(1 - \kappa)\cos^2 \phi] F(\kappa) \times$$

$$\exp\left[-\frac{(\theta_x - \gamma^{-1} \sqrt{\frac{1}{\kappa} - 1} \sin \phi)^2}{2\sigma_{\theta_x}^2}\right] \times \exp\left[-\frac{(\theta_y - \gamma^{-1} \sqrt{\frac{1}{\kappa} - 1} \cos \phi)^2}{2\sigma_{\theta_y}^2}\right]$$

$$\kappa = U/U_{\max} = (1 + \gamma^2 \theta^2)^{-1} \quad U_{\max} = 2\gamma^2 \hbar \omega$$

angle of observation

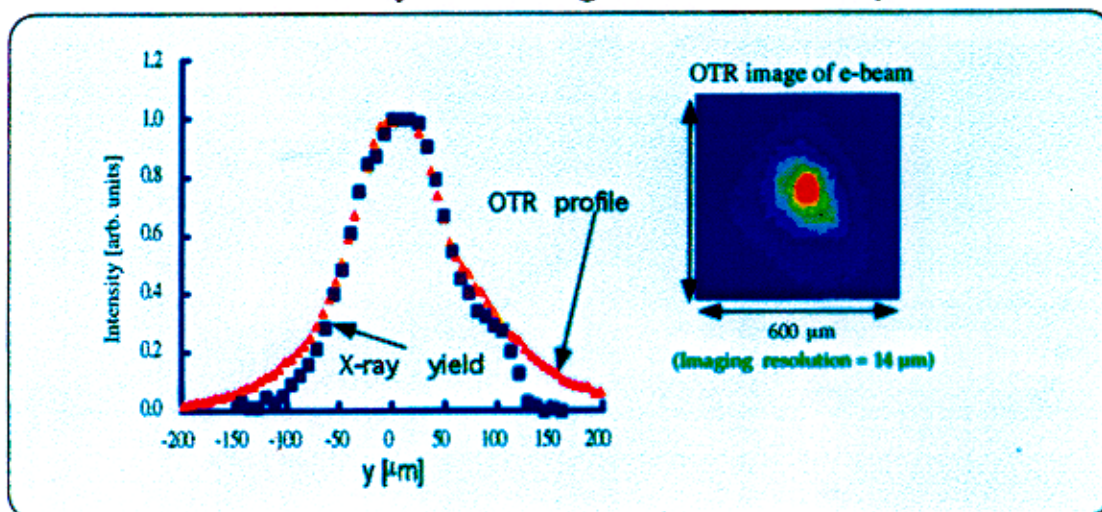


- Spectrum is acquired over 10,000 shots
- Data corrected for
  - window transmissivity
  - Ge efficiency
- Finite laser bandwidth included in modeling
- Spectral resolution  $\simeq 240 \text{ eV}$  (0.8%)
- Sensitivity calibrated with  $\text{I}^{129}$ ,  $\text{Am}^{241}$

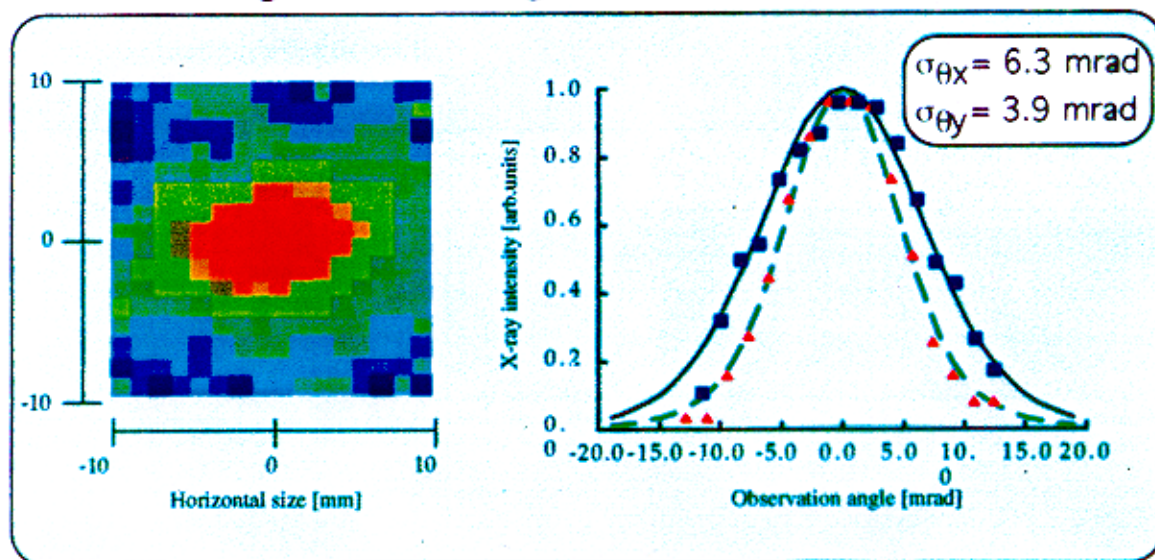
- Electron beam divergence = 3.5 - 4.0 mrad

# Transverse phase space information is obtained from 90° Thomson scattering

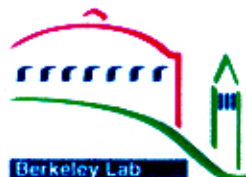
⇒ Vertical beam size is obtained by scanning laser vertically across electron beam



⇒ Beam divergence of a single 200 fs slice is obtained from the far field x-ray profile

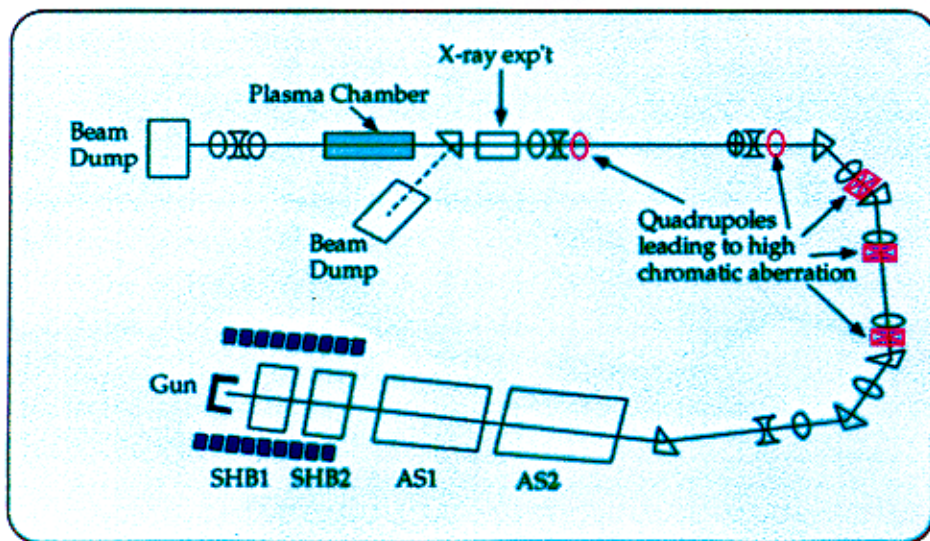


$$\frac{dP}{d\theta_x d\theta_y} \propto \int_0^{2\pi} d\phi \int_0^1 d\kappa F(\kappa) \kappa \left[ 1 - 4\kappa(1-\kappa)\cos^2\phi \right] \times \exp\left[-\frac{(\theta_x - \gamma^{-1}\sqrt{\frac{1}{\kappa}-1}\cos\phi)^2}{2\sigma_{\theta x}^2}\right] \exp\left[-\frac{(\theta_y + \gamma^{-1}\sqrt{\frac{1}{\kappa}-1}\sin\phi)^2}{2\sigma_{\theta y}^2}\right]$$

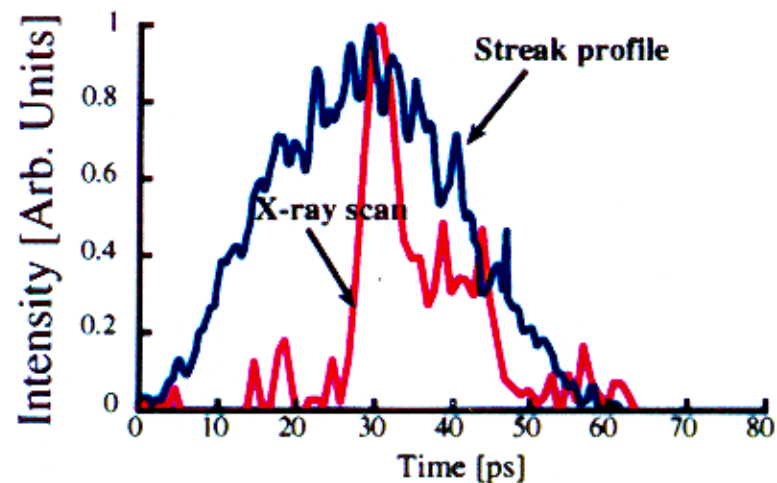


Chromatic aberrations in lattice were detected with laser probe, not with OTR

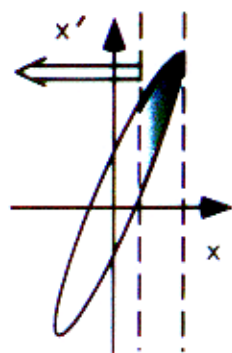
BTF lattice



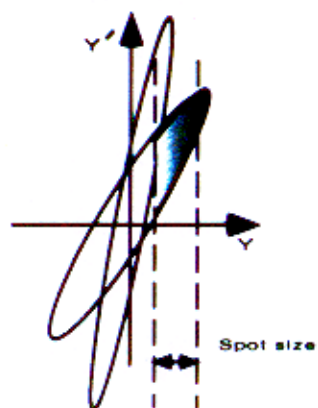
Large Chromatic aberrations



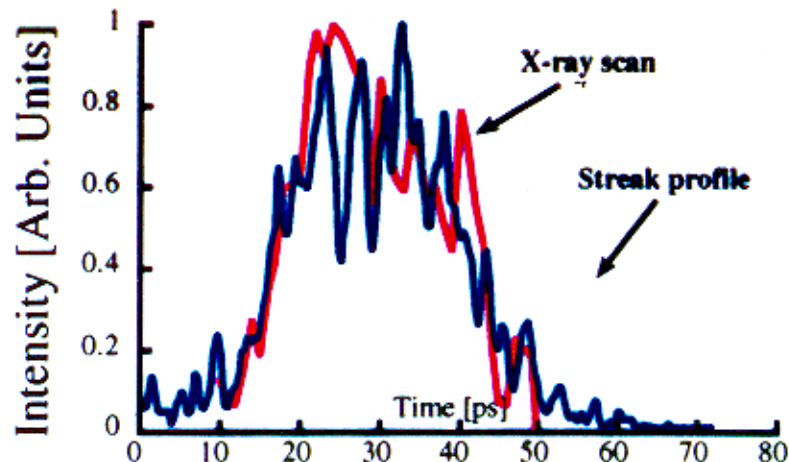
Horizontal phase space



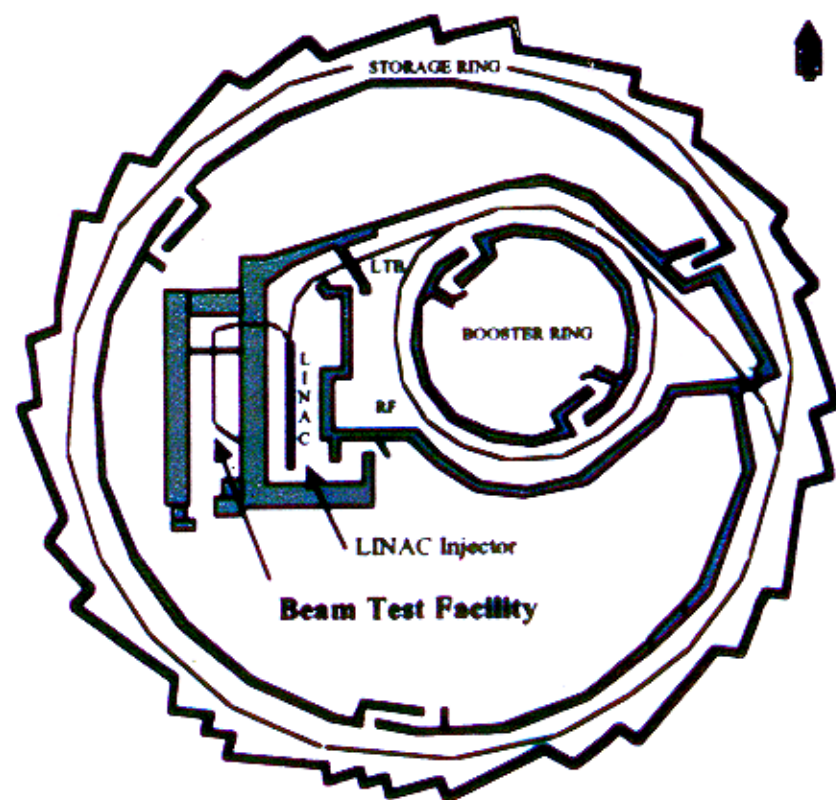
Vertical phase space



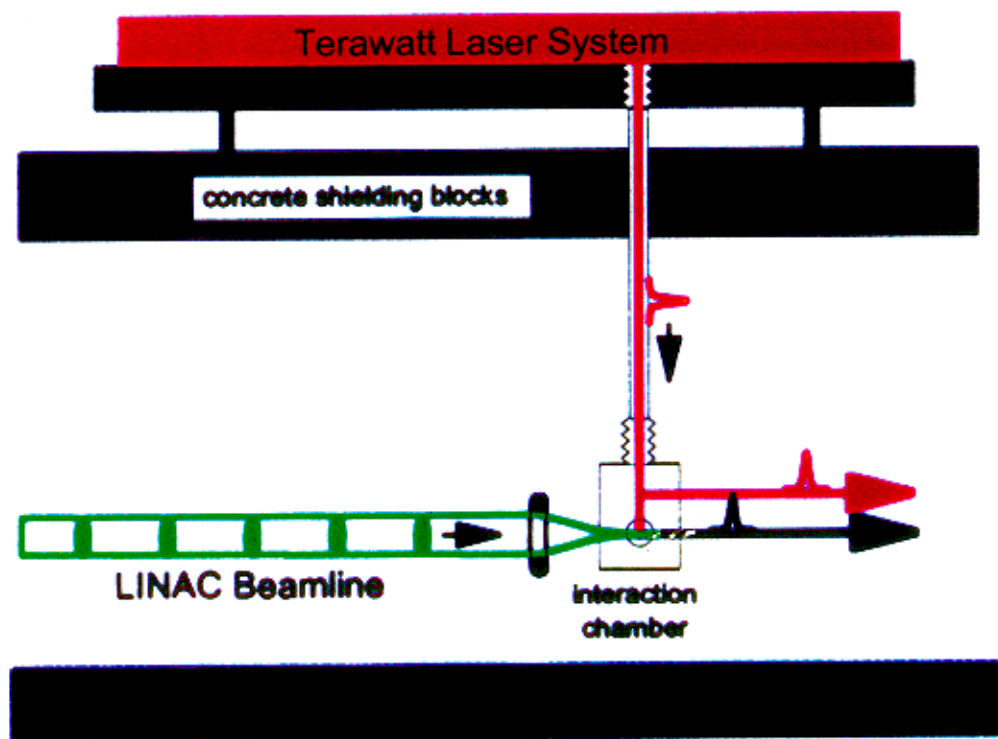
Small chromatic aberrations



# Thomson Source Layout at the Beam Test Facility\*



*Advanced Light Source*

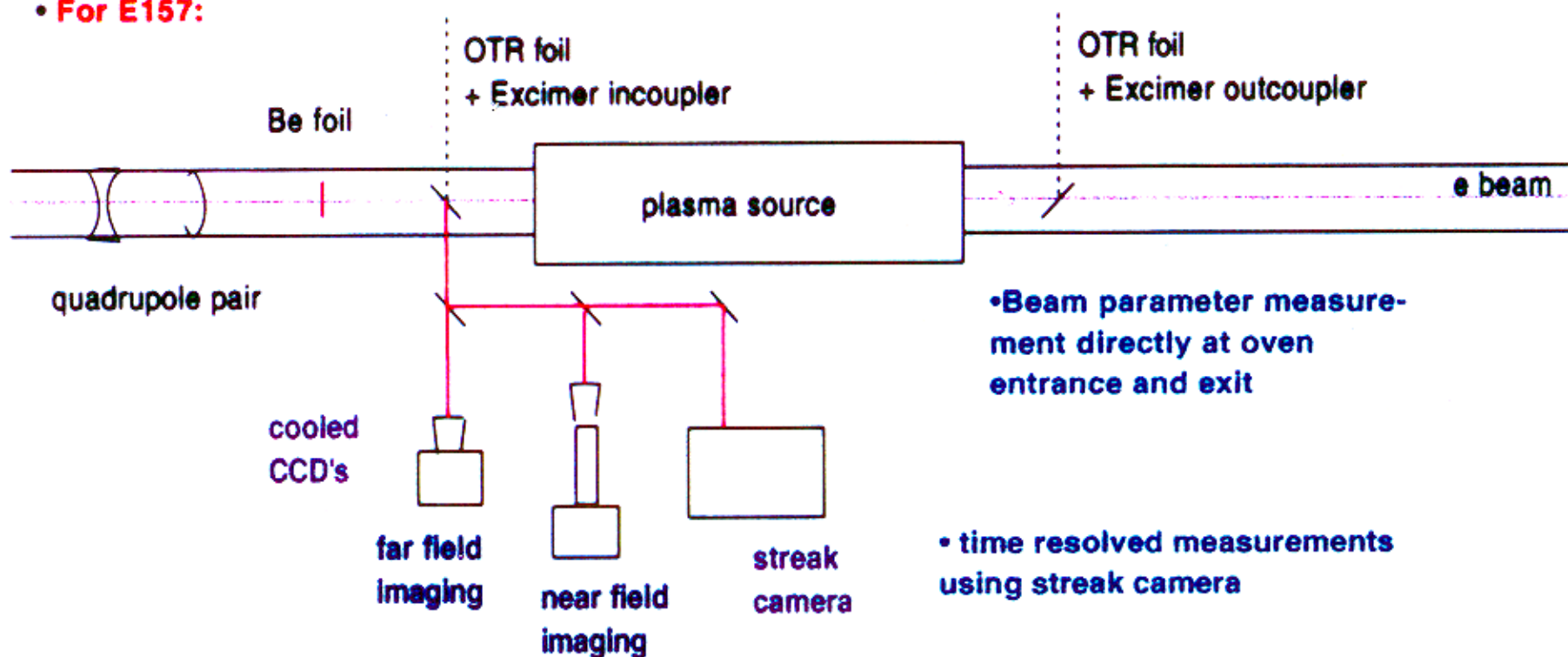




# OTR at 30 GeV - Motivation

- **In general:**  
-optical radiation-based diagnosis at multi-GeV energies

- **For E157:**

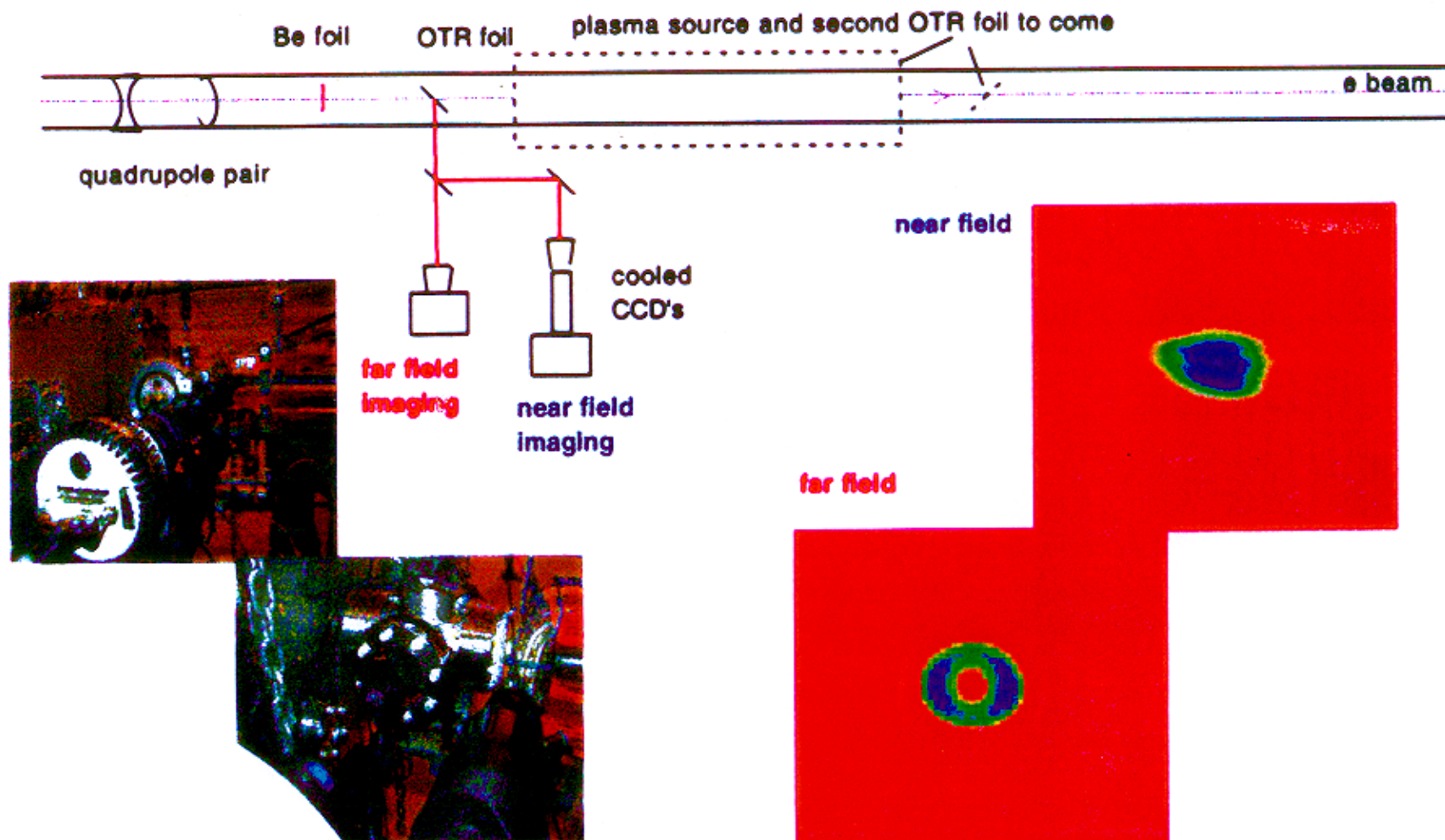


- spot size and divergence using spatial profile (present)
- bunchlength/spot size using fluctuations (future)

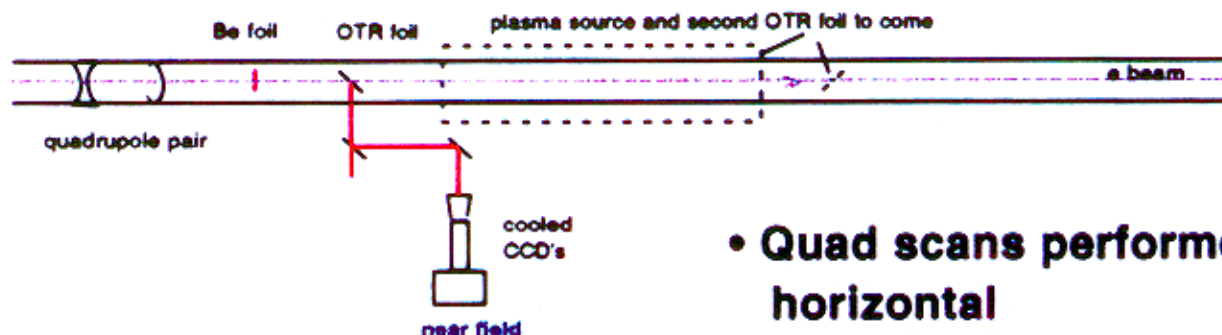


## OTR at 30 GeV - Experimental Setup

- Near and far field simultaneously imaged
- Two-foil interference observed in far field

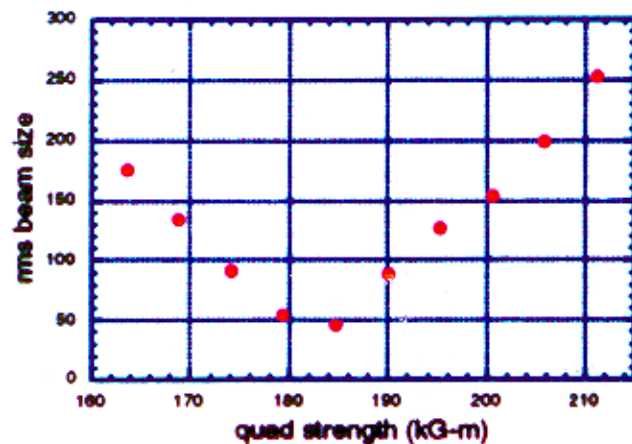


# OTR at 30 GeV - Beam spot size resolution

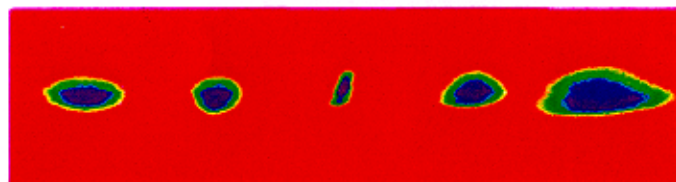
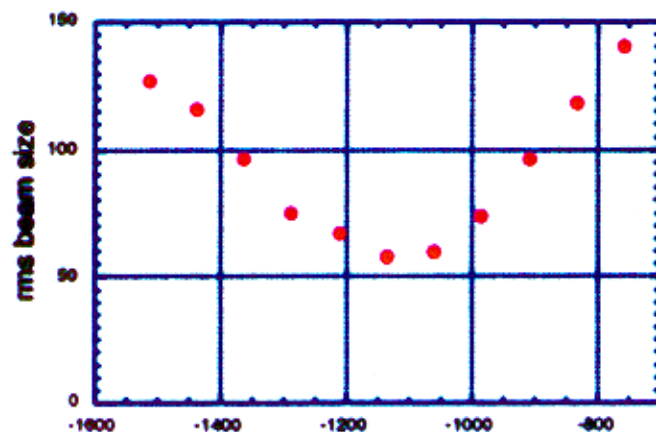


- Quad scans performed in vertical and horizontal
- 50 micron resolution achieved in both axes using visible wavelength OTR.

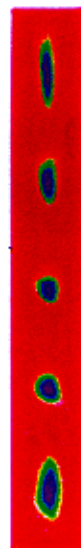
horizontal scan



vertical scan



← OTR near field images →





# OTR at 30 GeV - Beam divergence from 2-foil interference

Formation length (distance required to accumulate  $\pi$  phase shift):

$$L_f = \frac{\lambda}{\gamma^{-2} + \theta^2}$$

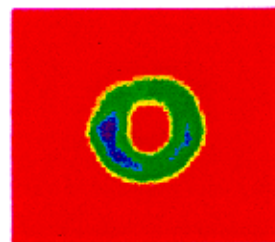
Intensity distribution:

$$\frac{d^2W}{d\omega d\Omega} = \frac{\theta^2}{(\gamma^{-2} + \theta^2)^2} \sin^2\left(\frac{L}{2L_f}\right)$$

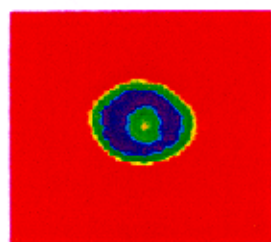
**At 30 GeV**  $\lambda=532$  nm,  $L=0.6$  m,  $L_f(\theta=1/\gamma) \sim 0.5$  km but:  $L_f(\theta=30/\gamma) \sim 0.6$  m - foil separation,  $L$

**2 foil interference patterns may be observed and utilized by collecting angles  $\gg 1/\gamma$**

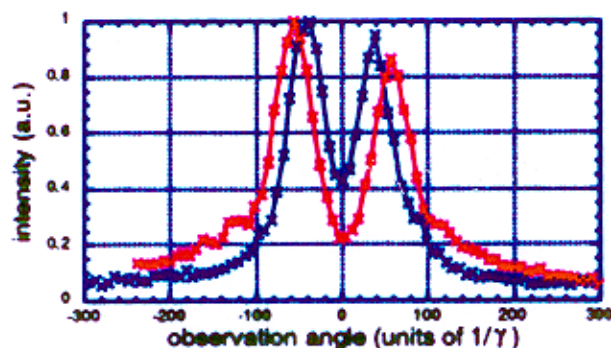
Wavelength dependence of measured intensity distribution and theory are in agreement.



800 nm



441 nm

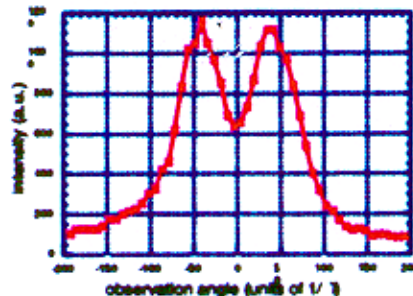
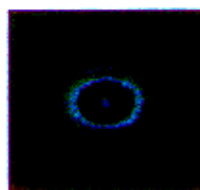


## Application: beam divergence calibration

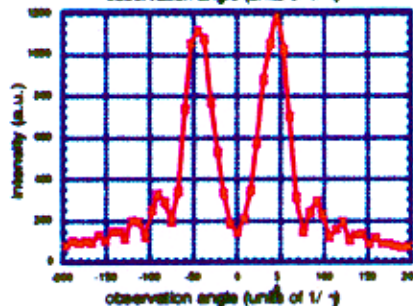
Sensitivity range adjustable via foil separation and wavelength BP.

Range of  $\sim 10$ - $50/\gamma$  demonstrated below

HIGH DIVERGENCE



LOW DIVERGENCE



- differing divergences in horizontal and vertical resolved;  
- divergence evolution during quad scan resolved